

VLSI Design, Fall 2017

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Homework No. 9

Assigned November 13, 2017, due November 20, 2017

1. (a) An ASIC uses a 65nm, 1V technology and has 500,000 gates, with 10,000 flip-flops connected in a scan chain using a Mux-Scan scheme as shown in Figure 1 below. The multiplexer has a propagation delay of 50 ps and a contamination delay of 30 ps. The flip-flop parameters are as follows.

CLK-Q: 40 ps
Setup time: 35 ps

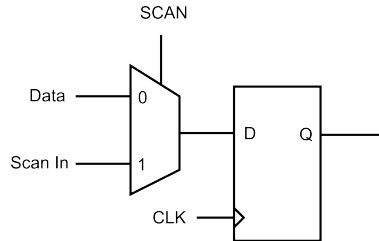


Figure 1: Mux-Scan Flip-Flop

How fast can the scan chain be clocked?

What is the maximum hold time allowable for the flip-flop at the above frequency?

What is the maximum hold time allowable for the flip-flop to enable the scan chain to be clocked at 1 GHz?

(b) The total gate length for the flip-flop (multiplexer and D-FF) is $7.5\mu\text{m}$, and the average gate length for a gate in the combinational logic is $4\mu\text{m}$. $C_g = 2fF/\mu\text{m}$. When the circuit is in scan mode, the combinational logic transitions have an activity factor of 0.2.

What is the power consumption of the circuit when the scan chain is clocked at 1GHz?

What is the clock speed for the power during scan to be kept below 500 mW?

If the subthreshold leakage is $15\text{ nA}/\mu\text{m}$ and the gate leakage is $0.1\text{ nA}/\mu\text{m}$, on the average, what is the static power consumption of the ASIC?

2. A ring oscillator is made up of 15 inverters in a 65nm technology with a supply voltage of 1 V. Each inverter is minimum sized (2:1). The FO4 inverter delay for this technology is 30 ps. The gate capacitance is $2\text{fF}/\mu\text{m}$.

What is the power consumption of the oscillator?

3. (a) Find a test for the node N stuck-at-0 in the circuit in Figure 2.

(b) Find the sequence of two tests which would detect that the nMOS transistor, labeled P, is slow to turn on.

4. Find test sequences $abcd \rightarrow abcd$ for the circuit in Figure 3 for the following faults.

(a) pMOS transistor with input b which is slow to turn on.

(b) nMOS transistor with input c which is slow to turn on.

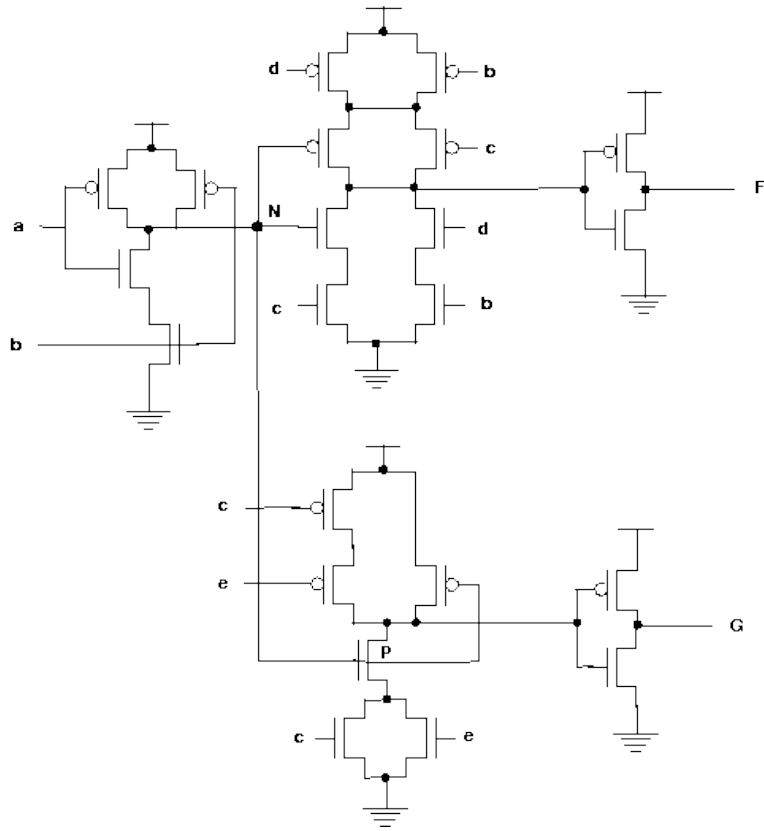


Figure 2: Test Generation

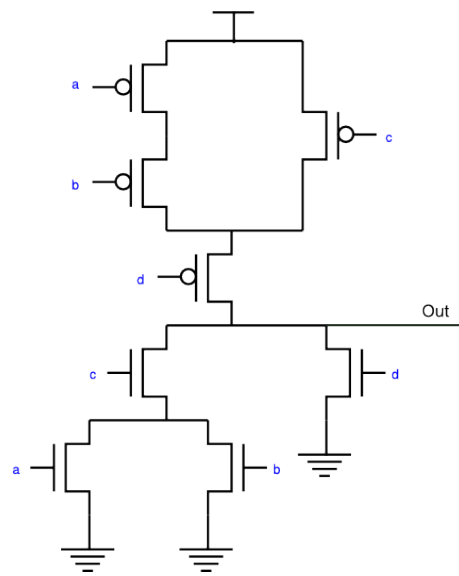


Figure 3: CMOS Complex Gate